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PATENT NUMBER and
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM	FILING DATE	CLASS	SUBCLASS	GAU	EXAMINER
10010850	12/05/2001	216 434	109	174	Adviser, B

APPLICANTS: Clevs Peggy; Mani Seethambal;

1765

CONTINUING DATA VERIFIED:

None BT

BEST AVAILABLE

CONTINUING APPLICATIONS VERIFIED:

None BT

DO NOT PUBLISH ☒

RESCIND ☐

Foreign priority claimed

☐ yes ☒ no

Foreign priority claims met

☐ yes ☒ no

Witness and Acknowledged Examiners's initials

BT

ATTORNEY DOCKET NO

SD6957S97604

TITLE: Schemes of a method for oxide sacrificial material in semiconductor device fabrication

U.S. DEPT. OF COMM. PAT. & TM. FTO-43 (Rev. 12-94)

NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED	
		Total Claims	Print Claims for O.G.
ISSUE FEE		DRAWINGS	
Amount Due	Date Paid	Sheets Drawg.	Figs. Drawg.
		Print Fig.	
<input type="checkbox"/> TERMINAL DISCLAIMER		Application Examiner	
Assistant Examiner		Primary Examiner	
PREPARED FOR ISSUE		WARNING: The information disclosed herein may be restricted. Unauthorized disclosure may be prohibited by the United States Code, Title 35, Sections 122, 181 and 368. Possession outside the U.S. Patent & Trademark Office is restricted to authorized employees and contractors only.	

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